IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Mamoru NAKASUJI et al. Group Art Unit: 2881

Serial No.: 09/891,511 Examiner: Jack I. Berman

Filed: **June 27, 2001** Confirmation No.: **8779**

For: INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND METHOD OF MANUFACTURING DEVICES USING THE SYSTEM

Attorney Docket Number: 010819

Customer Number: 38834

Date: January 25, 2006

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

This paper is filed in response to the Office Action dated August 25, 2005, the response date having been extended by two (2) months to January 25, 2006 by Petition for Extension of Time filed herewith.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 18 of this paper.